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***High-Power Laser Materials
Processing: Applications,
Diagnostics, and Systems X***

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Stefan W. Heinemann**
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Contents

PROCESS CONTROL

- 11679 08 **Depth monitoring system during laser processing using KTN-based wavelength-swept light source of 1.3- μm wavelength band** [11679-5]

WELDING

- 11679 09 **Laser beam welding with mobile vacuum: MoVac** [11679-6]

CUTTING AND DRILLING

- 11679 0C **Cutting and drilling of CFRP by using 3-kW CW single-mode fiber laser and galvanometer scanner** [11679-9]
- 11679 0E **Development of an on-the-fly percussion drilling process based on pulse bursts** [11679-11]

SURFACE TREATMENT

- 11679 0H **Development of high-power laser ablation process for polycrystalline diamond polishing: part 3. processing with an ultra-short-pulsed laser up to 1kW** [11679-14]
- 11679 0J **Application of nanoindentation technique to test surface hardness and residual stress of NiTi alloy after femtosecond laser shock peening** [11679-20]

OPTICAL SYSTEMS

- 11679 0L **Thermal lensing mitigation for high power laser processing** [11679-17]